

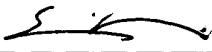
REMARKS

In response to the election requirement in the Office Action of April 16, 2003, Applicant(s) hereby elect without traverse the Species I, directed to a method for manufacturing a semiconductor device having the step of utilizing the third semiconductor film as a gettering site to reduce the metal element/crystallization promote material from the first semiconductor film. Claims 107-179 read on the elected species.

New claims 212-262 have been added to recite additional protection to which Applicant is entitled and also read on the above-elected Species I.

Examination on the merits is requested.

Respectfully submitted,


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